

INFORMATION DISCLOSURE CITATION FORM FOR PATENT APPLICATION (FORM PTO-1449) <small>APR 03 2006 (Substitute)</small>		Docket No.: 390-011420-US(PAR)		Serial No.: 10/628,980				
		Applicant(s): Blattner et al.						
		Filing Date: 7/29/03		Group: 1775				
U.S. PATENTS								
Initials	Patent Number	Issue Date	Name		Class	Sub-class		
			U.S. PATENT PUBLICATIONS					
Initials	Publication No.	Pub. Date	Name		Class	Sub-class		
ML	2002/0094257	7/18/02	Babbs et al.		414	277		
FOREIGN PATENT DOCUMENTS								
Initials	Document Number	Date	Country	Name		Translation? Yes/No/n/a		
ML	EP 1 052 547	11/15/00	EPO	ASM Lithography B.V. PRI Automation, Inc. TEC-SEM AG		yes		
ML	WO 02/08831	1/31/02	PCT					yes
ML	WO 02/01292	1/3/02	PCT					
OTHER DOCUMENTS (Title, Author, Date, Pages, Etc., if known)								
ML	European Search Report dated 12/1							
Examiner's Signature: /Michael Lowe/ (08/28/2006)				Date Considered: 08/28/2006				
Initial if reference was considered, whether or not citation is in conformance with MPEP. Mark through citation if not considered. Include a copy of this citation form with your next correspondence to the Applicant(s).								